## **WEST Search History**

Hide Items Restore Clear Cancel

DATE: Thursday, January 20, 2005

Hide?	<u>Set</u> <u>Name</u>	Query	<u>Hit</u> Count	
DB=PGPB, USPT, USOC; PLUR=YES; OP=ADJ				
	L9	L8 and 15	18	
	L8	134/1.3,3,26,28,30.ccls.	5972	
	$DB=EPAB,JPAB,DWPI,TDBD;\ PLUR=YES;\ OP=ADJ$			
	L7	((wafer or substrate or semiconductor) with (clean\$3 or remov\$3 or treat\$3)) same water same (ozone or 'O.sub.3') same (hydrogen or 'H.sub.2') same \$5sonic\$5	9	
	L6	L5	0	
	DB=PGPB, $USPT$ , $USOC$ ; $PLUR=YES$ ; $OP=ADJ$			
	L5	Ĺ4	45	
	DB = PGPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR = YES; OP = ADJ			
	L4	((wafer or substrate or semiconductor) with (clean\$3 or remov\$3 or treat\$3)) same water same (ozone or 'O.sub.3') same (hydrogen or 'H.sub.2') same \$5sonic\$5	54	
	L3	L1 same water same (ozone or 'O.sub.3') same (hydrogen or 'H.sub.2') same \$5sonic\$5	1	
	L2	L1 same (water with (ozone or 'O.sub.3') with (hydrogen or 'H.sub.2') with \$5sonic\$5)	0	
	L1	(wafer or substrate) with (bare or silicon oxide or 'SiO.sub.2') with (clean\$3 or remov\$3 or treat\$3)	11671	

END OF SEARCH HISTORY